



Thin Film Physical Sensor Instrumentation Research and Development at NASA Glenn Research Center

By -

BiblioGov. Paperback. Book Condition: New. This item is printed on demand. Paperback. 22 pages. Dimensions: 9.7in. x 7.4in. x 0.1in. A range of thin film sensor technology has been demonstrated enabling measurement of multiple parameters either individually or in sensor arrays including temperature, strain, heat flux, and flow. Multiple techniques exist for refractory thin film fabrication, fabrication and integration on complex surfaces and multilayered thin film insulation. Leveraging expertise in thin films and high temperature materials, investigations for the applications of thin film ceramic sensors has begun. The current challenges of instrumentation technology are to further develop systems packaging and component testing of specialized sensors, further develop instrumentation techniques on complex surfaces, improve sensor durability, and to address needs for extreme temperature applications. The technology research and development ongoing at NASA Glenn for applications to future launch vehicles, space vehicles, and ground systems is outlined. This item ships from La Vergne, TN. Paperback.



READ ONLINE
[3.05 MB]

Reviews

Absolutely essential go through pdf. It is written in simple terms and never difficult to understand. I am just very happy to let you know that this is actually the greatest pdf we have go through in my individual life and might be the greatest pdf for actually.

-- **Pete Bosco**

Very useful to any or all group of men and women. I am quite late in start reading this one, but better than never. You are going to like just how the blogger publish this book.

-- **Kristian Nader**